



Attorney's Docket No. 2390.P8276

Patent

#1418
42
5/27/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Anne E. Miller et al.

U.S. Serial No: 09/715,282

Filed: November 16, 2000

For: SLURRY AND METHOD FOR
CHEMICAL MECHANICAL
POLISHING OF COPPER

Commissioner For Patents
Box RCE
Washington, D.C. 20231

Confirmation No.: 6590

Examiner: Chen, Kin Chan

Art Unit: 1765

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PRELIMINARY AMENDMENT

Dear Sir:

In response to the Final Office Action mailed December 18, 2002 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith, Applicant respectfully requests the Examiner to enter this preliminary amendment and consider the remarks prior to examination of the above referenced case.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner For Patents, Box RCE, Washington, D.C. 20231

on March 18, 2003

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Date